

## **EUFANET**

Advances on Magnetic microscopy for 3D devices: increased resolution with very long working distance

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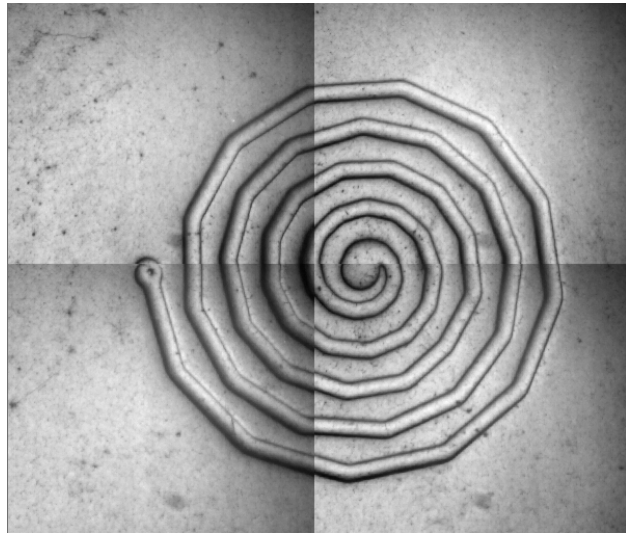
**Centre Nationale d'Etudes Spatiales (CNES)**

**Toulouse, France**

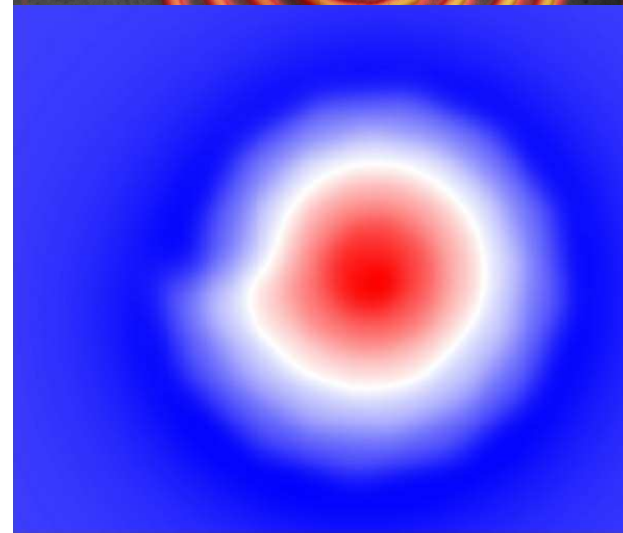
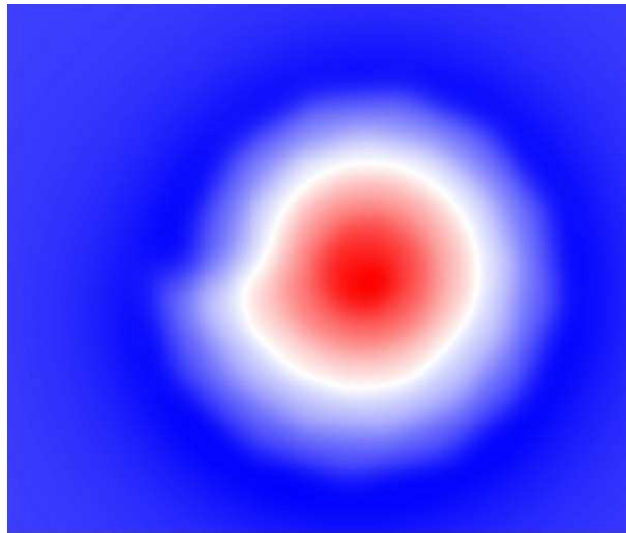
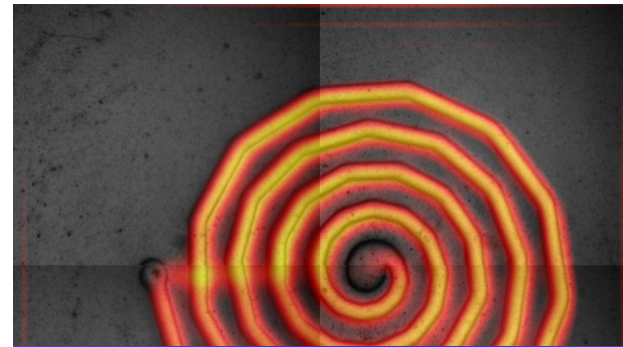
# Introduction

- **Magnetic Microscopy is a very powerful tool for failure localization**
- **The Magnetic Current Imaging technique generates a current cartography from the measurement of the magnetic field**
- **However, it has limited resolution due to the calculations performed on the data**
- **Furthermore, it can be applied to currents flowing up to few mm away from the magnetic probe**

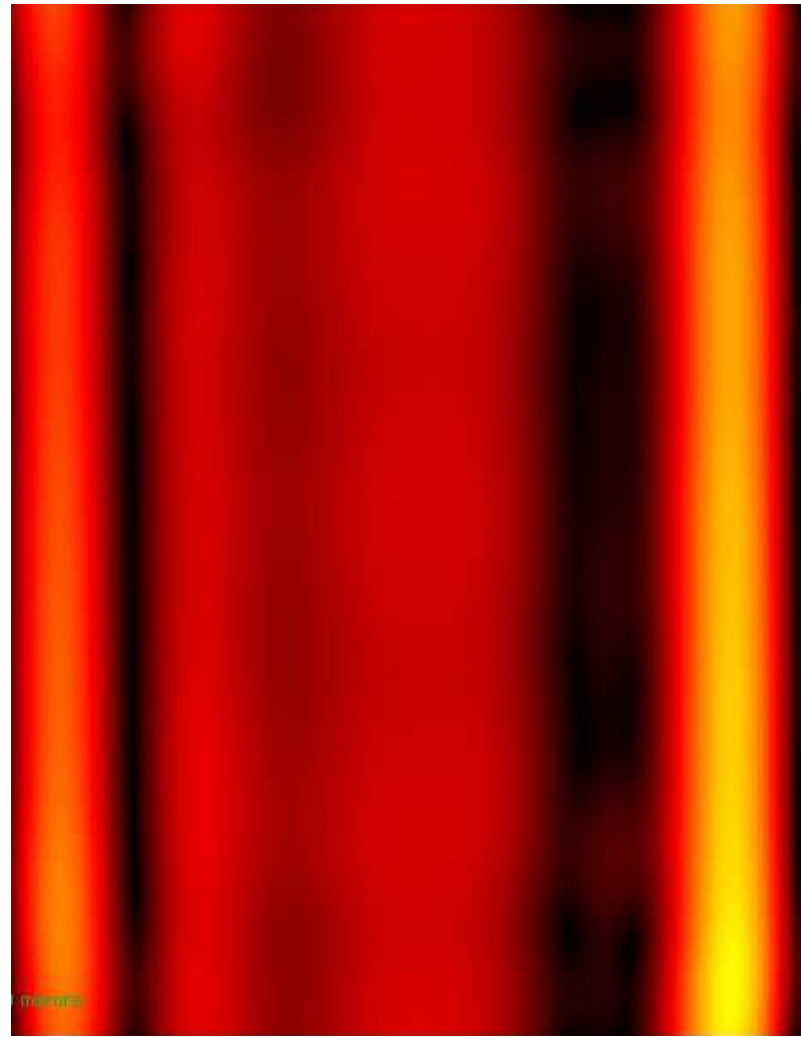
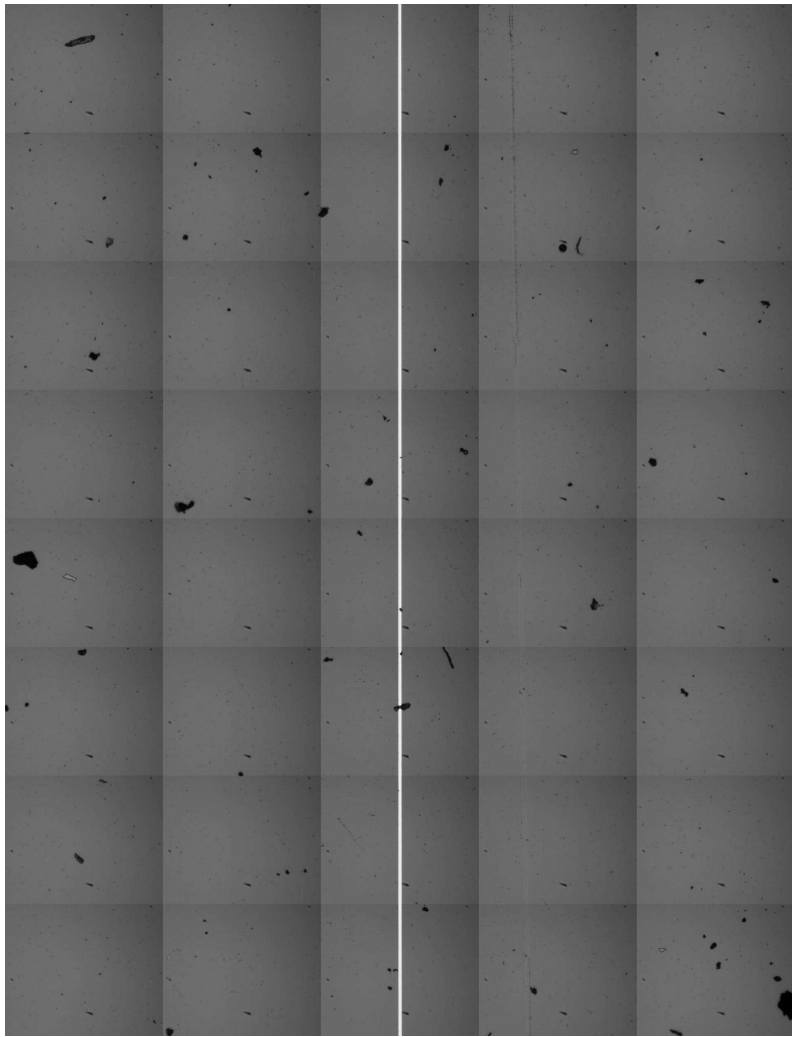
# 200um scan



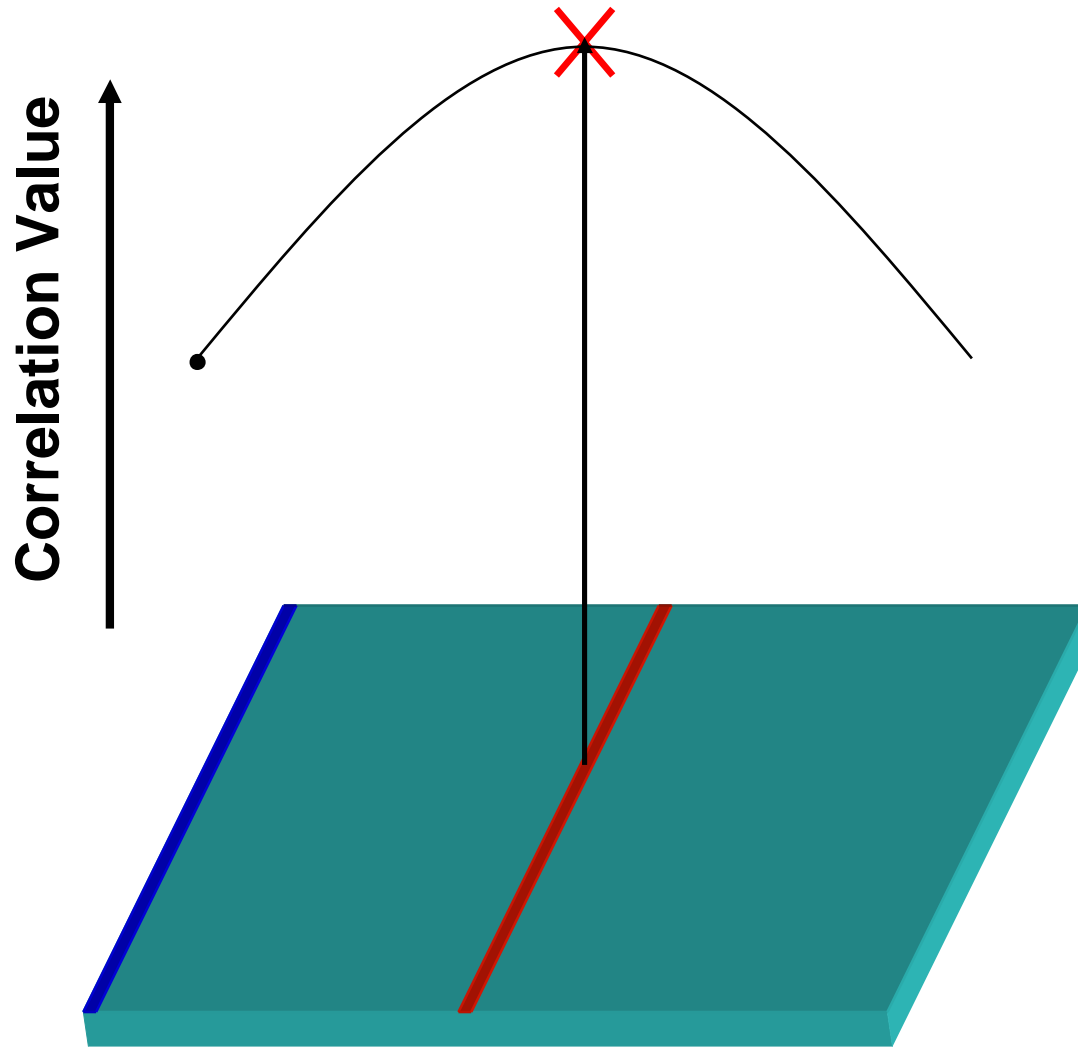
5.2mm



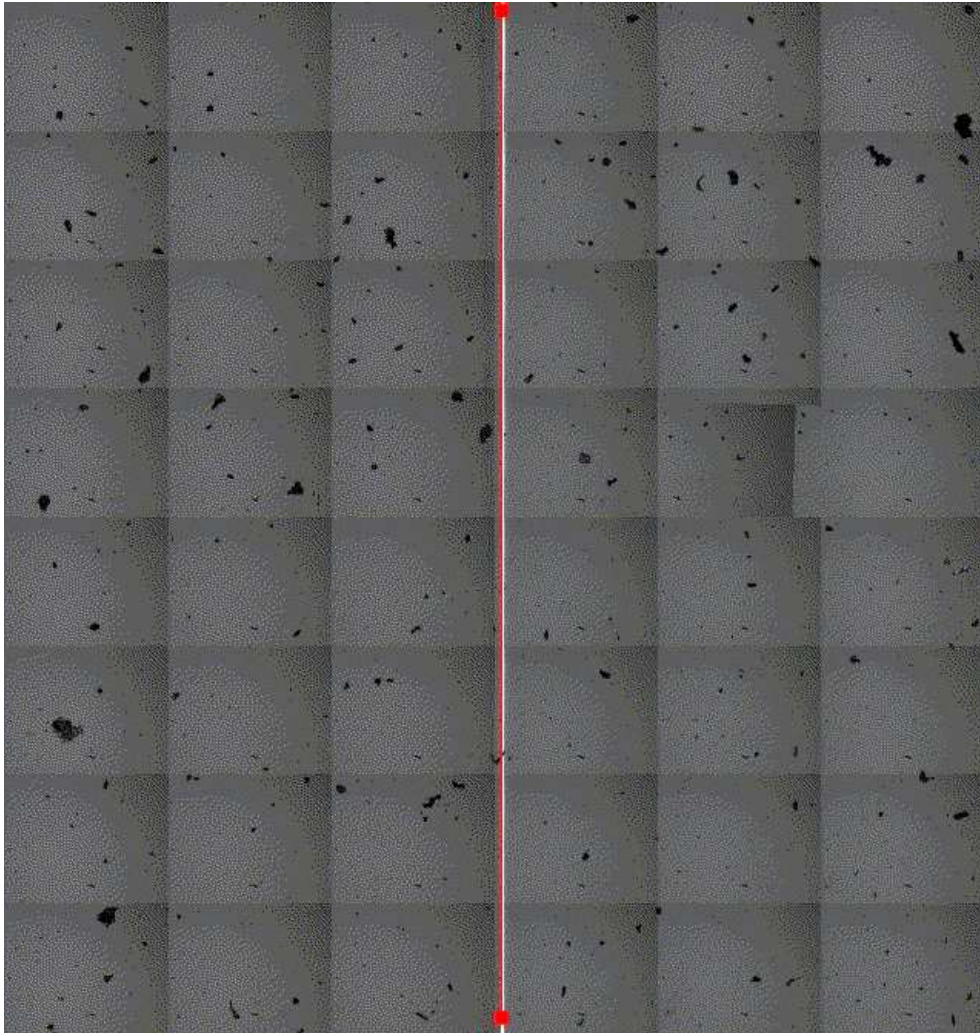
# 2cm line scan



# Evaluation of the Correlation



# Simulation approach results



**The position of the current line is found exactly where the path is situated**

# Results

- **Magnetic Microscopy is one of the more promising techniques for FA on 3D devices**
- **We are now able to map currents at a lot higher distance than before**
- **We increased the space resolution**
- **However, this technique is still to be improved:**
  - **Better resolution for even longer working distances can be achieved!**